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**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on May 17, 2002.

Joseph R. Jordan, Reg. No. 25,686

5/17/02  
Date

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No: 10/080,496  
Filing Date: February 22, 2002  
Art Unit: 1741  
Applicant: Jozef Brcka  
Title: MODIFIED TRANSFER FUNCTION DEPOSITION BAFFLES AND  
HIGH DENSITY PLASMA IGNITION THEREWITH IN  
SEMICONDUCTOR PROCESSING  
Atty Docket: TAZ-213

Cincinnati, Ohio

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

**RECEIVED** May 17, 2002  
**MAY 23 2002**  
**TC 1700**

**INFORMATION DISCLOSURE STATEMENT**

In accordance with the duty of candor and good faith imposed by 37 CFR §1.56 and means of complying therewith according to 37 CFR §§1.97 and 1.98, the references listed on the attached PTO-1449 are called to the attention of the United States Patent and Trademark Office in connection with the above-identified patent application. Copies of the cited references are enclosed herewith. No admission is made that the cited art represents the prior art or that the cited art is the most material art.

The Examiner is urged to consider the cited references and to make an independent decision with respect to their materiality.

Respectfully submitted,

WOOD, HERRON & EVANS, L.L.P.

By

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